



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re U.S. Patent application:)
Hisato SHINOHARA et al.)
Application Serial No. 08/169,127) Art Unit: 1762
Filed: December 20, 1993) Examiner: Marianne L. Padgett
For: LASER IRRADIATION METHOD) Date: June 27, 2006
(AS AMENDED)

AMENDMENT

Mail Stop **AMENDMENT**
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed December 27, 2005, please consider the following amendments and remarks in connection with this instant application.